



Attorney Docket No. 09799940-0120

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

**PATENT  
RECEIVED  
OCT 24 2003  
TC 1700**

In re Patent Application of:

**Thinghao F. Wang**

Application No. 10/071,809

Filed: **February 7, 2002**

For: **METHOD FOR SELECTIVELY  
ETCHING SILICON AND/OR  
METAL SILICIDE**

) Group Art Unit: 1765

) Examiner: **Deo, Duy Vu**

) **Certificate of Mailing (37 CFR 1.8(a))**  
) I hereby certify that this paper (along with  
) any paper referred to as being attached  
) or enclosed) is being deposited with the  
) United States Postal Service on the date  
) shown below with sufficient postage as  
) first class mail in an envelope addressed  
) to the Commissioner for Patents, P.O. Box 1450,  
) Alexandria, VA 22313-1450, on:

)   
) Paul E. Rauch, Ph.D.

) Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**NOTICE OF APPEAL**

Dear Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner dated May 16, 2003, finally rejecting claims 1, 3-12, 14, 15, 21-23, 25, 27. Pursuant to 37 C.F.R. § 1.17(b), the fee for this Notice of Appeal is \$330.00. PTO Form 2038 is enclosed to cover the required fees.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Dated: October 16, 2003

By:

  
Paul E. Rauch, Ph.D.

Registration No. 38,591

SONNENSCHN NATH & ROSENTHAL LLP

P.O. Box 061080

Wacker Drive Station, Sears Tower

Chicago, Illinois 60606-1080

(312) 876-8000

10/23/2003 AWDNAF1 00000033 10071809

01 FC:1401

330.00 DP